Notice of References Cited Application/Control No. 10/705,892 Examiner Jacques Veillard Applicant(s)/Patent Under Reexamination LEE, SU-JEONG Art Unit Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-5,802,352	09-1998	Chow et al.	715/517
*	В	US-6,151,623	11-2000	Harrison et al.	709/206
*	С	US-6,243,861	06-2001	Nitta et al.	717/108
*	D	US-6,178,545	01-2001	Nagashima et al.	717/108
*	Ε	US-6,681,234	01-2004	Sokolov et al.	707/206
*	F	US-5,809,507	09-1998	Cavanaugh, III, Ken M.	707/103R
*	G	US-6,119,125	09-2000	Gloudeman et al.	707/103R
*	Н	US-6,141,595	10-2000	Gloudeman et al.	700/83
*	1	US-6,557,165	04-2003	Nagashima et al.	717/108
	J	US-			
	К	US-			
	L	US-			
	М	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	Ν					
	0					
	Р					
	Q					
	R					
	s					
	Т					

NON-PATENT DOCUMENTS

*	ļ	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)				
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	x					

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